



DEC 23 2005

IFW

Docket No. 5000-5118

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Tomohei SUGIYAMA et al. Group Art Unit: 2891
Serial No : 10/626,418 Examiner: D. Menz
Filed : July 23, 2003
For : METHOD OF MANUFACTURING A LOW EXPANSION MATERIAL
AND SEMICONDUCTOR DEVICE USING THE LOW EXPANSION
MATERIAL

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action (non-final rejection) dated September 22, 2005,
Applicants respectfully request reconsideration in view of the following amendments and
remarks.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Amendments to Figure 9 are attached.

Remarks/Arguments begin on page 5 of this paper.